

<b>Notic of References Cited</b>	Application/Control No. 09/200,495		Applicant(s)/Patent Under Reexamination VAN BUSKIRK ET AL.	
	Examiner Shouxiang Hu		Art Unit 2811	Page 1 of 1

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	B	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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